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(MIZUSHIMA,Ichiro) [JP/JP]; 〒240-0015 神奈川県 横浜市保土ヶ谷区 岩崎町 2 0-1-3 0 7 Kanagawa

(JP).

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100-0013 東京都千代田区 霞が関3丁目7番2号 鈴 榮特許綜合法律事務所内 Tokyo (JP).

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国際調査報告書

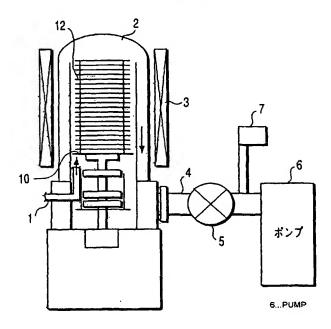
(72) 発明者; および

(75) 発明者/出願人 (米国についてのみ): 水島 一郎

2文字コード及び他の略語については、定期発行される 各PCTガゼットの巻頭に掲載されている「コードと略語 のガイダンスノート」を参照。

(54) Title: PURGING METHOD FOR SEMICONDUCTOR PRODUCTION DEVICE AND PRODUCTION METHOD FOR SEMICONDUCTOR DEVICE

(54) 発明の名称: 半導体製造装置のパージ方法及び半導体装置の製造方法



(57) Abstract: A purging method for a semiconductor production device comprising the step of etching, by a cleaning gas containing at least halogen gas, a CVD deposit film deposited in a chamber (2) constituting a semiconductor production device that has formed a CVD film on a semiconductor wafer (12) by a CVD method, and the step of purging, after the step of etching the above CVD deposit film by a cleaning gas, a cleaning gas remaining in the chamber (2) by passing a hydrogen-containing gas through the chamber (2).

# WO 03/019634RNATIONAL SEARCH REPORT

International :PCT/JP02/08742
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| A. CLASSIFICATION OF SUBJECT MATTER Int.Cl <sup>7</sup> H01L21/205, C23C16/44  |  |  |                             |  |  |
|--|--|--|-----------------------------|--|--|
| According to International Patent Classification (IPC) or to both national classification and IPC  |  |  |                             |  |  |
|  | SEARCHED   |  |                             |  |  |
|  | ocumentation searched (classification system followed  |  |                             |  |  |
| Int.Cl <sup>7</sup> H01L21/205, 21/306, 21/3065, C23C16/44   |  |  |                             |  |  |
| Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched  |  |  |                             |  |  |
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| C. DOCUMENTS CONSIDERED TO BE RELEVANT   |  |  |                             |  |  |
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| ▼ Furthe   | r documents are listed in the continuation of Box C.   | See patent family annex.                   |                             |  |  |
| Special categories of cited documents:     "T" later document published after the international filing date or   |  |  |                             |  |  |
| "A" docume   | nt defining the general state of the art which is not  | priority date and not in conflict with the | ne application but cited to |  |  |
| considered to be of particular relevance understand the principle or theory underlying the invention  "E" earlier document but published on or after the international filing "X" document of particular relevance; the claimed invention cannot |  |  |                             |  |  |
| date considered novel or cannot be considered to involve an inventive  |  |  | red to involve an inventive |  |  |
| cited to establish the publication date of another citation or other "Y" document of particular relevance; the claimed invention cannot be   |  |  | claimed invention cannot be |  |  |
| special reason (as specified)  "O"  document referring to an oral disclosure, use, exhibition or other  combined with one or more other such documents, such   |  |  | when the document is        |  |  |
| means combination being ob   |  |  | skilled in the art          |  |  |
| "P" document published prior to the international filing date but later "&" document member of the same patent family than the priority date claimed   |  |  |                             |  |  |
|  | Date of the actual completion of the international search  Date of mailing of the international search report                |  |                             |  |  |
| 26 No  | ovember, 2002 (26.11.02)   | 10 December, 2002 (                        | 10.12.02)                   |  |  |
| Name and mailing address of the ISA/ A   |  | Authorized officer                         |                             |  |  |
| Japanese Patent Office   |  |  |                             |  |  |
| Facsimile No   | ) <u>.</u>   | Telephone No.                              |                             |  |  |

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# INTERNATIONAL SEARCH REPORT

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International application No.
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